

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	<b>MAIL STOP PETITIONS</b>
Nathan S. Lewis	)	Group Art Unit: 2813
Application No.: 09/905,157	)	Examiner: COLLEEN E. RODGERS
Filed: July 12, 2001	)	Confirmation No.: 2732
For: ELECTRICAL PASSIVATION OF SILICON-CONTAINING SURFACES USING ORGANIC LAYERS	)	Certificate of Electronic Deposit
	)	I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office on August 25, 2008 via EFS-Web.
	)	By: <u>/Joseph R. Baker, Jr./</u>
	)	Joseph R. Baker, Jr.
	)	

**AMENDMENT/REPLY TRANSMITTAL LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed is a Petition with Withdrawal Abandonment or in the alternative a Petition to Revive an Unintentionally Abandoned Application.

- ☒ Also enclosed is/are: Petition, Substitute Drawings, Request for Withdrawal of Abandonment
- ☒ Small entity status is hereby claimed.

Respectfully submitted,

GAVRILOVICH, DODD & LINDSEY LLP

Date August 25, 2008

By: /Joseph R. Baker, Jr./  
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